

# Stanford

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## Andreas Werbrouck

Postdoctoral Scholar, Chemical Engineering

### Bio

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#### STANFORD ADVISORS

- Stacey Bent, Postdoctoral Faculty Sponsor
- Stacey Bent, Postdoctoral Research Mentor

### Publications

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#### PUBLICATIONS

- **Plasma-enhanced atomic layer deposition: Correlating O<sub>2</sub> plasma parameters and species to blister formation and conformal film growth** *JOURNAL OF VACUUM SCIENCE & TECHNOLOGY A*  
Werbrouck, A., van de Kerckhove, K., Depla, D., Poelman, D., Smet, P. F., Dendooven, J., Detavernier, C.  
2021; 39 (6)